



IPW
Docket No. 1232-4609US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kazuaki OHMI, et al.

Group Art Unit: 2812

Serial No.: 10/602,922

Examiner: Angel ROMAN

Filed: June 25, 2003

For: SEPARATING APPARATUS, SEPARATING METHOD, AND METHOD OF
MANUFACTURING SEMICONDUCTOR SUBSTRATE

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Official Action December 21, 2004, Applicants respectfully
request reconsideration in view of the following amendments and remarks.

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.